

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor	:	Yasushi HAYASHIDA, et al.	CONF. NO.: 4274
U.S. Serial No.	:	10/551,225	
Group Art Unit	:	3651	
Filed	:	September 28, 2005	
Examiner	:	Ramya G. Prakasam	
For	:	SUBSTRATE PROCESSING SYSTEM, AND METHOD OF CONTROL THEREFOR, CONTROL PROGRAM, AND STORAGE MEDIUM	

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 19, 2008, please amend the above-identified application as set forth below and consider the following remarks.

Amendments to the Claims begin on page 2.

Remarks begin on page 4.